SIEMENS

PATENT Attorney Docket No. 2003P06024WOUS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor:	F. Diedrich et al.) Group Art Unit:	1797
Serial No.:	10/554,162) Examiner:	Clemente, Robert Arthur
Filed:	08/07/2006) Confirmation No.:	6581
Title:	GAS CHROMATOGRAPH AND METHOD FOR GAS (CHROMATOGRAPHIC	

Mail Stop AF **Commissioner For Patents** P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR 1.116

Sir:

In response to the Office Action mailed 25 November 2008 applicants respectfully submit the following amendment and remarks in connection with a request for allowance of the above-identified application. Entry of this amendment is respectfully requested under 37 CFR 1.116 since it places the application into condition for allowance in accordance with the Examiner's finding of allowable subject matter.

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